	04-10-2001					
RI		HEET	Docket Number ATMI 510			
TO THE HOPE Please reco	FO THE H: 101673490 PATENTS AND TRADEMARKS: Please record the attached original document or copy thereof.					
Thomas H. B. Chongying X Bryan C. Hen Jeffrey F. Roo	u drix 3/30/20/	2. Name and address Advanced Technology 7 Commerce Drive Danbury, Connecticut Additional name(s attached? \square	y Materials, Inc. 06810 and addresses	11040 U.		
3. Nature of c	onveyance:					
☑ Assignment ☐ Other	☐ Merger ☐ Security	Agreement	nge of Name			
Execution Date	: March 29, 2001, March 29, 2	2001, March 29, 2001, Marc	h 30, 2001			
If this docu	number(s) or patent number(s) ment is being filed together wis: March 29, 2001 and March	ith a new application, the	•			
A. Tatent App		s attached? \square Yes \square No	o			
5. Name and address of party to whom correspondence concerning document should be mailed: Margaret Chappuis Advanced Technology Materials, Inc. 7 Commerce Drive Danbury, Connecticut 06810 Telephone: 203-794-1100		 7. Total Fee (37 CFR 3.41): \$ 40 ☑ Enclosed ☐ Authorized to be charged to deposit account 				
	er of applications and patents	8. Deposit account no 50-0860	umber:			
	DO NOT USE	THIS SPACE				
	ny knowledge and belief, the fo opy is a true copy.	Margaret	ue and eprrect and Chappuis 5, 45,735			

PATENT REEL: 011669 FRAME: 0333

ASSIGNMENT

We have made an invention described in the U.S. Patent Application entitled "SOURCE REAGENT COMPOSITIONS FOR CVD FORMATION OF GATE DIELECTRIC THIN FILMS USING AMIDE PRECURSORS AND METHOD OF USING SAME" which has been executed by us on the same date as this Assignment for filed in the United States Patent and Trademark Office.

We assign to Advanced Technology Materials, Inc., 7 Commerce Drive, Danbury, Connecticut 06810, all of our ownership and rights in:

- (i) the invention and U.S. Patent Application;
- (ii) U.S. Patents on the invention; and
- (iii) corresponding foreign patent applications and patents.

We are making this assignment based on our relationship with Advanced Technology Materials, Inc.

We request the Commissioner of Patents and Trademarks of the United States and the appropriate officers of all foreign countries to issue patents on the invention to Advanced Technology Materials, Inc.

We agree to execute any other legal documents that may be required to effectuate this Assignment.

We agree that we will promptly communicate to Advanced Technology Materials, Inc. all facts that come to our attention affecting the invention or patent rights.

We agree that we will testify in any interference or litigation involving the invention or patent rights.

We state that we have not previously taken any action in conflict with this Assignment.

Page 1 of 2

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RECORDED: 03/30/2001